

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant : Kiyoshi Arita et al.
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INFORMATION DISCLOSURE STATEMENT

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Sir/Madam:

In accordance with Rule 56, applicants are aware of the publications listed in the International Search Report (ISR, copy enclosed) and in the enclosed copy of Patent Office Form 1449. Copies of the publications cited in the International Search Report are not enclosed as they were previously forwarded by the International Bureau, however, a copy of each publication cited in the specification is enclosed.

If there are any fees required by this communication, please charge such fees to our Deposit Account No. 16-0820, Order No. 39102.

Respectfully submitted,

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U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date if Appropriate
	A	2003/37882 A1	02/2003	Arita et al.			
	B	6,583,979 B1	06/2003	Takahasi et al.			
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	L	1 132 948 A2	09/2001	EUROPE			Cited on ISR
	M	1 215 716 A1	06/2002	EUROPE			Cited on ISR
	N	10-223725	08/1998	JAPAN			Cited in Specification-English Abstract
	P	2001-77184	03/2001	JAPAN			Cited on ISR
	Q	2001-210622	08/2001	JAPAN			Cited in Specification-English Abstract

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

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